



1-26-04

Docket No. 7471/CMP/RKK

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Re: Inventor(s): Robert Tolles, David P. Alvarez and Jianshe Tang  
Title: MEGASONIC WAFER CLEANING TANK WITH REFLECTOR FOR IMPROVED WAFER EDGE CLEANING  
Serial No.: 10/736,242  
Filed: December 15, 2003

Transmitted herewith is:

- ☒ Information Disclosure Statement  
☒ PTO Form 1449 with one cited reference  
☒ Return Postcards

FEE CALCULATION					
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	N/A	- 20 =	-0-	X \$18.00	\$0.00
Independent Claims	N/A	- 3 =	-0-	X \$84.00	\$0.00
Basic Filing Fee				\$740.00	\$0.00
TOTAL FEES					\$0.00

\_\_\_ The Commissioner is hereby authorized to charge \$0.00 to Deposit Account No. 04-1696.

☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 04-1696. A duplicate copy of this transmittal is enclosed.

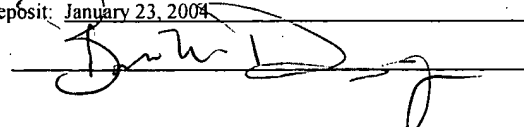
☒ Please address all future correspondence to:

**PATENT COUNSEL  
APPLIED MATERIALS, INC.  
Legal Affairs Department  
P.O. BOX 450A  
Santa Clara, CA. 95052**

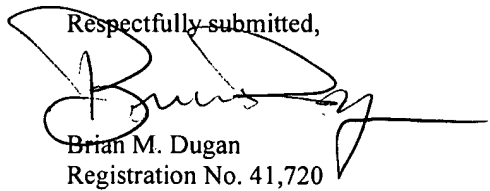
I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Express Mail Receipt No. EL975550275US

Date of Deposit: January 23, 2004

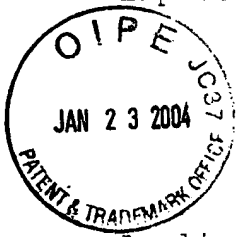
Signature: 

Respectfully submitted,

  
Brian M. Dugan  
Registration No. 41,720  
(914) 332-9081

Express Mail Label No. EL975550275US

PATENTS  
7471/CMP/RKK



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Robert Tolles, David P. Alvarez and Jianshe Tang  
Serial No. : 10/736,242  
Filed : December 15, 2003  
For : MEGASONIC WAFER CLEANING TANK WITH REFLECTOR  
FOR IMPROVED WAFER EDGE CLEANING

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

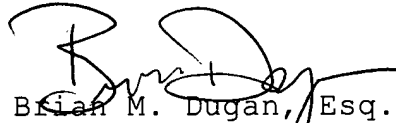
In accordance with 37 C.F.R. §§ 1.56 and 1.97,  
applicants wish to call the attention of the Examiner to the  
following references:

U.S. Patent No. 6,460,551 B1, Fishkin et al.

These references are also listed on the accompanying  
Information Disclosure Statement (Form PTO-1449) and copies are  
enclosed.

Consideration of the foregoing in relation to this  
patent application is respectfully requested.

Respectfully Submitted,

A handwritten signature in black ink, appearing to read "Brian M. Dugan", is written over the typed name.

Brian M. Dugan, Esq.  
Registration No. 41,720  
Dugan & Dugan, PC  
Attorneys for Applicants  
(914) 332-9081

Dated: January 23, 2004  
Tarrytown, New York

U.S. Department of Commerce, Patent and Trademark Office  <div style="border: 1px solid black; border-radius: 50%; padding: 10px; width: 100px; margin: 0 auto; text-align: center;">           LIST OF RELEVANT ART CITED BY APPLICANT            (Use several sheets if necessary)  <b>JAN 23 2004</b>            PATENT &amp; TRADEMARK OFFICE         </div>				Docket No.: 7471/CMP/RKK		Serial No.: 10/736,242	
Applicants: Robert Tolles, David P. Alvarez and Jianshe Tang							
Filing Date: December 15, 2003						Group: _____	

U.S. Patent Documents							
*Examiner Initial	Document Number	Issue Date	Name	Class	Subclass	Filing Date If Appropriate	
	US-1	6,460,551 B1	Fishkin et al.				
	US-2						
	US-3						
	US-4						
	US-5						
	US-6						
	US-7						
	US-8						
	US-9						
	US-10						
	US-11						

Foreign Patent Documents							Translation	
	Document Number	Date	Country	Class	Subclass	Yes	No	
	F-1							
	F-2							
	F-3							
	F-4							
	F-5							

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)	
	OT-1
	OT-2
	OT-3

Examiner	Date Considered
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.